September 1, 2004

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	Application Number	Unassigned	10/50

Filing Date

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

First Named Inventor Youngyul KIM
Art Unit Unassigned

Examiner Name Unassigned

(Use as many sheets as necessary) Examiner Name Unassigned

Sheet 1 of 1 Attorney Docket Number 61282.00015

U.S. PATENT DOCUMENTS							
Examiner Cite Initials • No.1	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pagas, Columns, Lines, Where Relevant			
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Examiner Cite No.1	011-	Foreign Patent Document		N	Pages, Columns, Lines, Where Relevant	
	Country Code ³ - Number ⁴ - Kind Code ⁵	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Passages or Relevant Figures Appear	۳	
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Complete if Known Application Number 10/506,558 September 1, 2004 Filing Date Youngyul KIM First Named Inventor Art Unit Not yet assigned. Examiner Name Not yet assigned.

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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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